

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10578369	TAKAMIZAWA ET AL.
	Examiner	Art Unit
	Robert M Kunemund	1792

SEARCHED

Class	Subclass	Date	Examiner
117	94,95,96, 105	3/10/08	RMK

SEARCH NOTES

Search Notes	Date	Examiner
west: etch, bake, dop, silicon substrate	3/10/08	RMK

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner